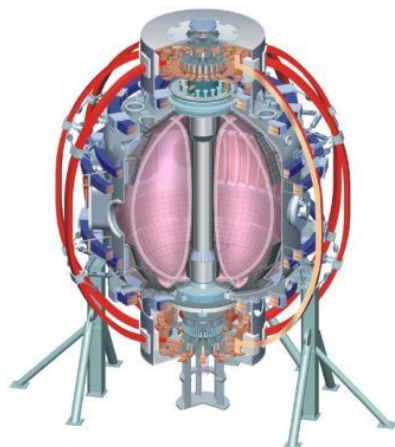


# Optimization of ELM pace-making with 3D Fields

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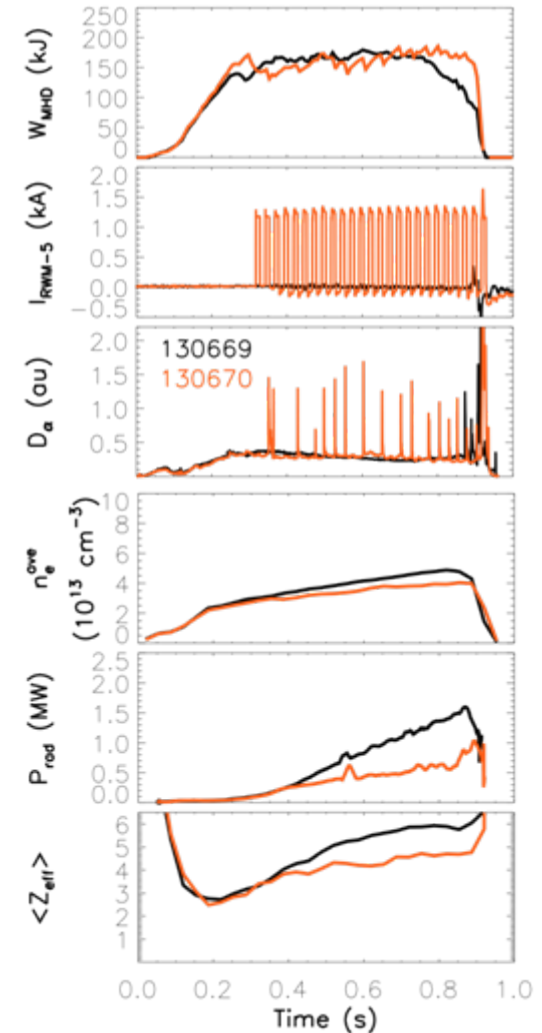
**NSTX XP Review**  
**Princeton, NJ**  
**May 6, 2009**



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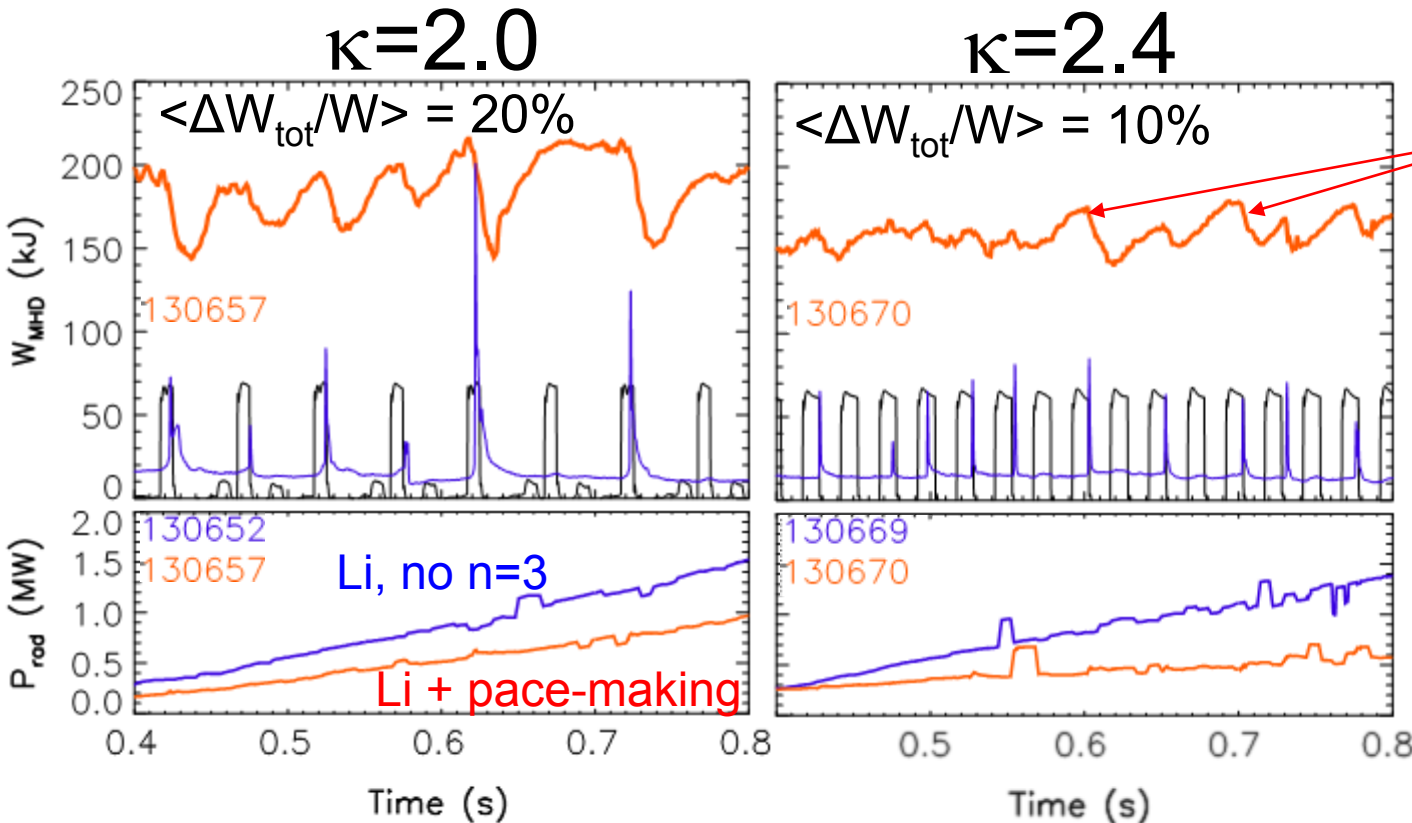
# ELM Pacing can reduce impurity buildup during Li-enhanced discharges

- ELM-free H-mode shots have very large radiated power
- ELM pacing able to control this problem
- Need to develop scenario for long-pulse, steady-state



# ...but the triggered ELMs are very large

- ELMs are much smaller at high  $\kappa$ 
  - Most probable ELM size is  $\Delta W_{\text{tot}}/W \sim 3\%$  at  $\kappa=2.4$ ,  $\sim 20\%$  at  $\kappa=2.0$
  - Triggering frequency also higher
  - As is effectiveness in reducing  $P_{\text{rad}}$  buildup



Largest ELMs occur after pulse fails to trigger

Triggering requires 8-10 ms pulses, comparable to  $\sim 4$  ms field penetration time

# Goal of XP: Li + n=3 high performance plasma with small ELMs and steady density/ $P_{\text{rad}}$

- 1) Produce reference discharge (2 shots)
  - Reload 132592:  $I_p=1.0$  MA,  $B_t=0.45$  T,  $\kappa=2.2$ ,  $\delta=0.8$ ,  $dr^{\text{sep}}\sim -1$  cm,  $P_{\text{NBI}} = 3$  MW, LITER at  $\sim 50$  mg/min, 600 mg/shot
  - Change  $dr^{\text{sep}}$  to  $\sim 0$ ,  $\kappa$  to 2.5, adjust LITER to 40 mg/min,  $\sim 300$  mg/shot (1 shot)
  - If necessary, increase LITER evaporation rate to get ELM-free conditions (1)
  
- 2) Waveform optimization: maximize frequency, minimize duty cycle of n=3 (13 shots)
  - Starting values from 130670, but lower frequency to reduce braking: 1.2 kA, 11 ms pulses, 20 Hz repetition (1 shot)
  - Increase amplitude as much as possible to try to trigger ELMs faster (3 shots)
    - SPA current scan at fixed pulse width: 1.5, 2.0, 2.5 kA
  - At highest current, decrease pulse length as much as possible with reliable triggering (2 shots)
  - Increase frequency as much as possible, until excessive braking leads to termination of discharge (3 shots)
  - Add short ( $\sim 2$  ms) SPA current reversal to the end of each pulse, test if this allows further increase in pulse frequency (2 shots)

# Goal of XP: Li + n=3 high performance plasma with small ELMs and steady density/ $P_{\text{rad}}$



- 3) Shape optimization: minimize ELM size, maximize frequency (12 shots)
  - Reduce  $\kappa$  to 2.1
    - start with best SPA waveform from series 2) (1 shot)
    - reduce pulse frequency until triggering is reliable (2 shots)
  - Raise  $\kappa$  to 2.7 in increments of 0.2. At each shape perform the following:
    - apply low-frequency SPA waveform from  $\kappa = 2.1$  case (1 shot)
    - increase frequency as much as possible while maintaining reliable triggering (2 shots)
- 4) Fueling optimization: minimize  $dn/dt$  (10 shots)
  - Start with reference discharge, and change CS in increments of 100 torr
  - Replace CS with shoulder
    - Shoulder pressure at  $\sim$  half CS
    - Shoulder puff at 100-130 ms ( $\sim$ 10-30 ms later than CS)
  - Replace CS with SGI?
- 5) Vacuum shots with SPA pulses ( $\sim$ 5 shots)
  - Restore best SPA waveforms from day, measure vacuum field structure
  - Special machine requirements
    - 10 min shot cycle (no HeGDC), LITER sufficient to suppress ELMs
      - Several control shots will be taken through the day to check LITER rate is enough
    - RWM coils configured for n=3